

PATENT ASSIGNMENT

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CONVEYING PARTY DATA	
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The University of North Carolina at Chapel Hill	03/23/2007
RECEIVING PARTY DATA	
Name:	National Science Foundation
Street Address:	4201 Wilson Blvd
Internal Address:	Room 1265
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State/Country:	VIRGINIA
Postal Code:	22230
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Property Type	Number
Application Number:	11594023
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PATENT
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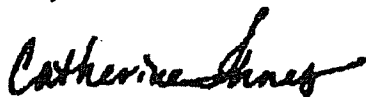
Invention Title: Methods for Fabricating Isolated Nanostructures using Soft Lithography
Inventor(s): Joseph DeSimone, Edward T. Samulski, Jason Rolland and Ansley Exner
Patent or Application Serial No.: 60/583,170, 60/691,607, 60/714,961, 60/762,802, 60/799,867, 10/583,570, 60/833,736 and 11/594,023
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Foreign Applications filed/intended in (countries): PCT/US2004/042706, filed 12/20/04, PCT/US2006/023722, filed 6/19/06 and PCT/US2006/034997, filed 9/7/06 Australia, Brazil, Canada, China, Europe, India, Indonesia, Israel, Japan, Korea, Mexico, Singapore and South Africa

The invention identified above is a Subject Invention under 35 U.S.C. 200, et seq., and the Standard Patent Rights clause at 37 CFR 401.14 or FAR 52.227-11, which are included among the terms of the above-identified grant/contract award from the National Science Foundation. This document is confirmatory of:

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The Government is hereby granted an irrevocable power to inspect and make copies of the above-identified patent application.

Signed this 23rd day of March 2007.



By _____
Catherine Innes, Director

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